

Notice of References Cited	Application/Control No. 10/561,455	Applicant(s)/Patent Under Reexamination TAEKEMA ET AL.	
	Examiner RAMON O. RAMIREZ	Art Unit 3632	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,254,044	07-2001	Lee, Li-Hwa	248/177.1
	B	US-			
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	D	US-			
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	J	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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